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APPLICANTS

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** CONTINUING DATA *****

none

** FOREIGN APPLICATIONS *****

JAPAN P2002-223614 07/31/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>Fourson</i> Initials <i>CF</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 2
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TITLE

Ion implantation method, SOI wafer manufacturing method and ion implantation system

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